Date Mailed: July 29, 2003

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	FORM	1449*	

INFORMATION DISCLOSURE STATEMENT

IN AN APPLICATION

(Use several sheets if necessary)

Docket Number:	Application Number:
HSJ920030016US3	

Applicant: GILL et al.

Filing Date: 07/29/2003 Group Art Unit: unassigned

EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS		DATE OPRIATE
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14	JP11045415A	1999-02-16	JP			Abstract only	
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EXAMINER	A.	Heinz	DATE CONSIDERED	7/	12/05			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.								

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ORM 1449* SUPPLEMENT	AL INFORMATION DISCLOSURE STATEMENT	Docket Number: HSJ920030016US3	Application Number: 10/629,323	
011 87	IN AN APPLICATION	Applicant: Gill et al.		
n enes (C)	(Lice caveral cheets if necessary)	Filing Date: 7/29/2003	Group Art Unit: 2651	

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